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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10039357	FILING DATE 11/07/2001	CLASS 257	SUBCLASS	GAU 2811	EXAMINER ZELVIGON
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**CONTINUING DATA VERIFIED:

** FOREIGN APPLICATIONS VERIFIED
REPUBLIC OF KOREA 2000-65873 11/07/2000

27 3/21/3

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed 35 USC 112 conditions met Priority and Acknowledged Examiner's initals		ATTORNEY DOCKET NO TJK 203-LW
TITLE : Apparatus and method for thin film deposition		

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	
ISSUE FEE		DRAWING		
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.	Print Fig.
TERMINAL DISCLAIMER		Primary Examiner		
		PREPARED FOR ISSUE Application Examiner		
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